Search Notes

App	licat	ion/C	ontro	ol No.

Applicant(s)/Patent under Reexamination

DEKKER ET AL.

Art Unit

Chris C. Chu

10/572,982

Examiner

2815

SEARCHED					
Class	Subclass	Date	Examiner		
257	E23.008, E23.073 & E23.174	8/16/2007	C.C.		
257	E23.193	8/16/2007	C.C.		
257	E25.029	8/16/2007	C.C.		
257	676 & 686	8/16/2007	C.C.		
257	689 & 728	8/16/2007	C.C.		
257	735	8/16/2007	C.C.		
357	74 & 75	8/16/2007	C.C.		

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
Searched in US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; FPRS; and IBM_TDB;	8/16/2007	C.C.		